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(54) **LIQUID CRYSTAL DISPLAY**

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(57) **ABSTRACT**

A liquid crystal display includes, for an embodiment, a first insulation substrate; a gate line extending in a first direction on the first insulation substrate; a data line insulated from the gate line and extending in a second direction; a pixel electrode formed in a pixel area defined by the intersection of the gate line and the data line; and storage wiring formed with the same layer as the data line, wherein the storage wiring includes a storage electrode extending in the first direction and covering the gate line, and a storage line connected to the storage electrode and formed according to the second direction.

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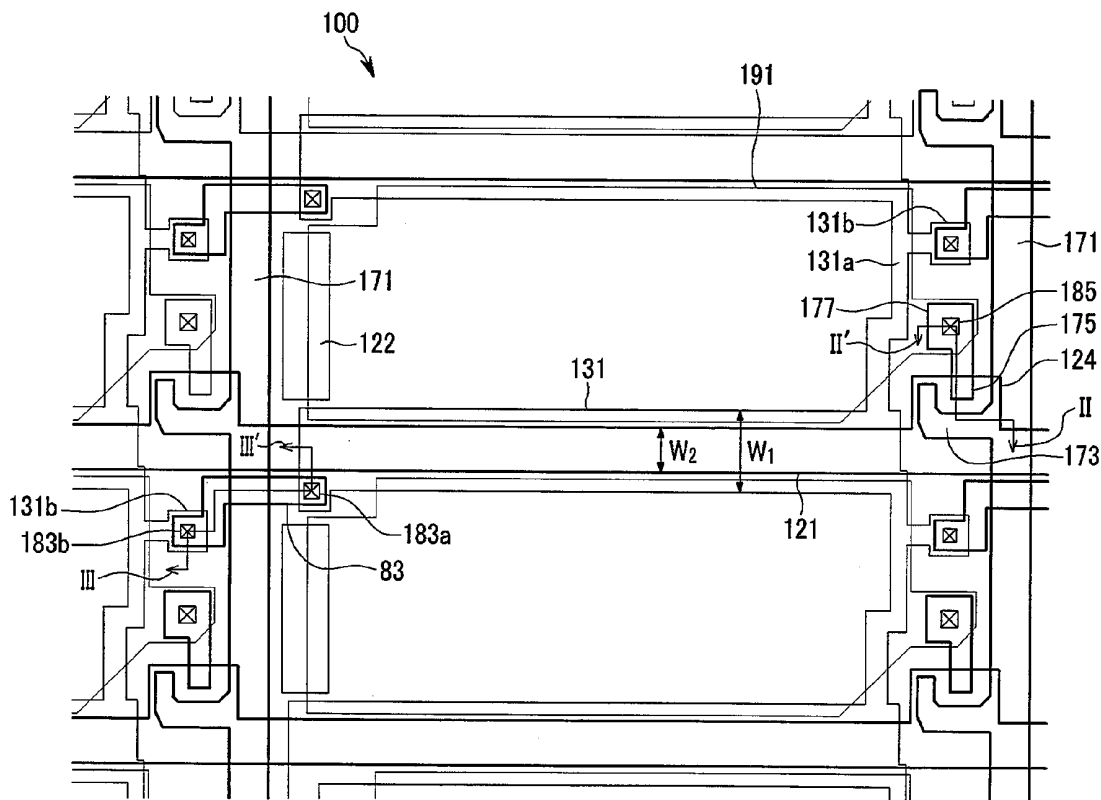


FIG. 2

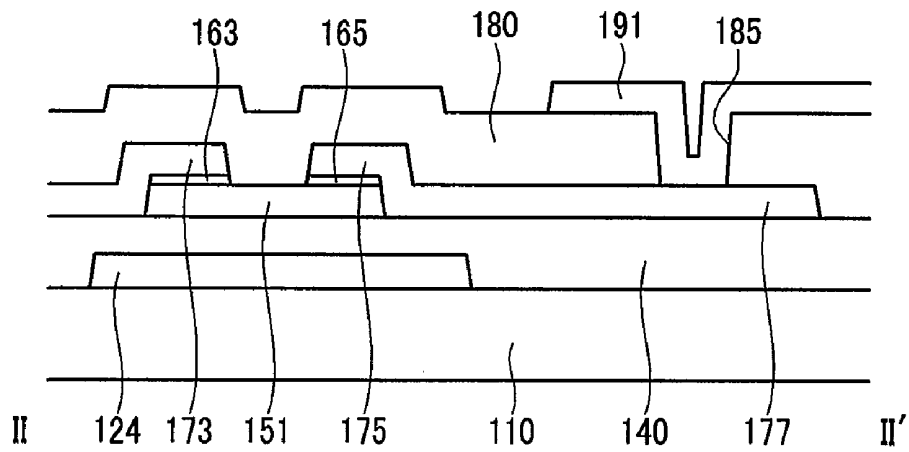


FIG. 3

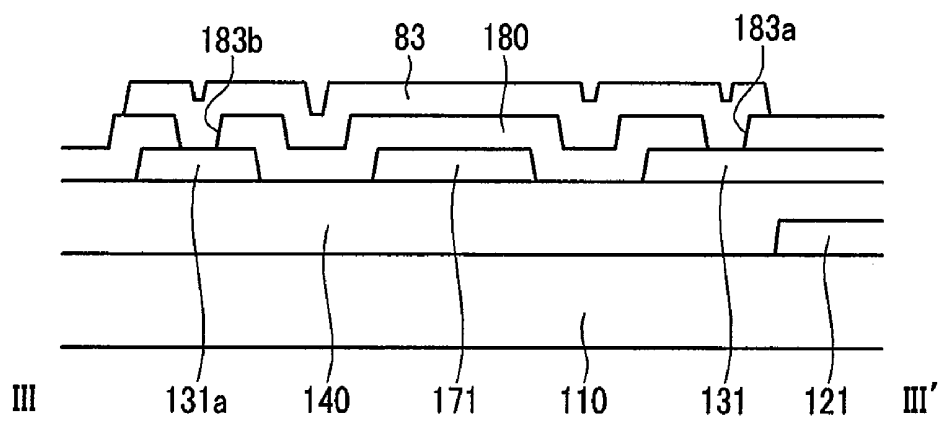


FIG. 4

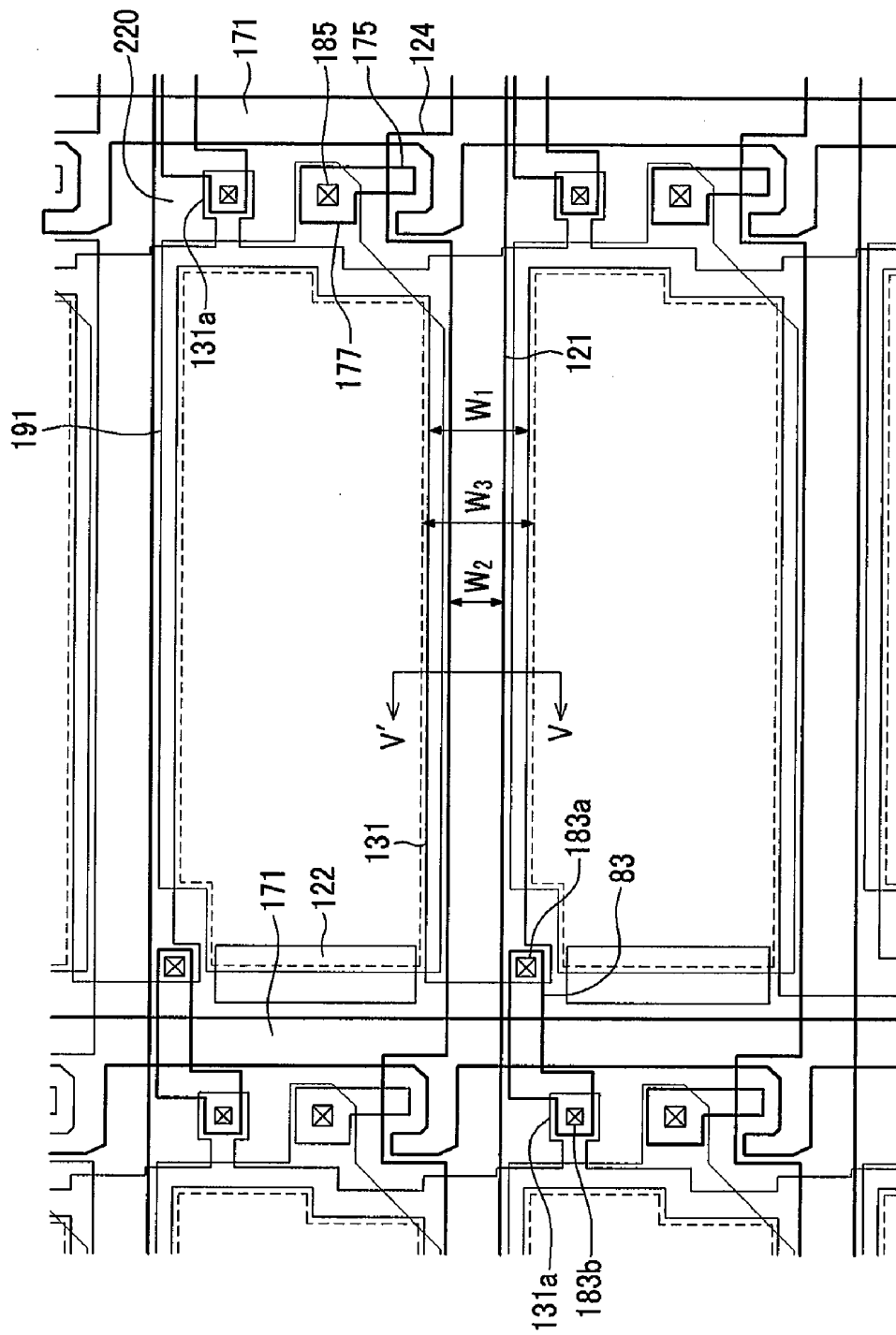
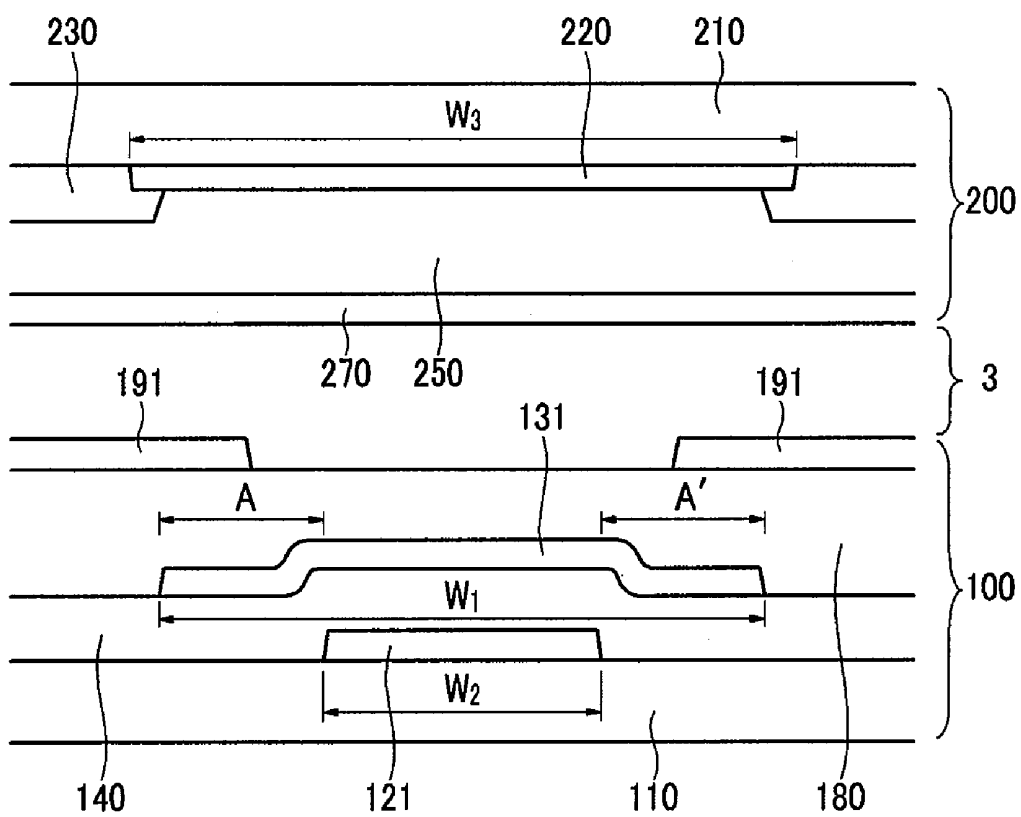


FIG. 5



LIQUID CRYSTAL DISPLAY

CROSS-REFERENCE TO RELATED APPLICATIONS

[0001] This application claims priority to and the benefit of Korean Patent Application No. 10-2008-0094629 filed in the Korean Intellectual Property Office on Sep. 26, 2008, the entire contents of which are herein incorporated by reference.

BACKGROUND

[0002] 1. Technical Field

[0003] The present invention relates to liquid crystal displays and, more particularly, to a liquid crystal display having a transverse pixel structure.

[0004] 2. Related Art

[0005] Typically, a liquid crystal display includes a common electrode panel having a common electrode and a thin film transistor array panel having a thin film transistor array. The common electrode panel and the thin film transistor array panel face each other and are combined by a sealing line interposed between the two display panels, with a liquid crystal layer formed in the space between the two display panels. This liquid crystal display including the two panels is provided with field-generating electrodes, between which the liquid crystal layer is interposed. This liquid crystal display displays images by applying voltages to the field-generating electrodes to generate an electric field in the liquid crystal layer that determines the orientations of liquid crystal molecules therein to control the amount of transmitted light. The liquid crystal display is a non-emissive device such that a backlight unit for providing the light on the rear of the thin film transistor array panel is provided. The amount of transmittance of light that is irradiated by a backlight is controlled according to the arrangement of the liquid crystal molecules.

[0006] The thin film transistor array panel includes a plurality of gate lines, data lines, and pixel electrodes. The gate lines extend in the row direction and transmit gate signals, and the data lines extend in the column direction and transmit data signals. The pixel electrodes are connected to the gate lines and the data lines, and to a plurality of switching elements and storage capacitors.

[0007] The switching elements are disposed at portions where the gate lines and the data lines intersect each other, and each switching element is a three terminal element including a control terminal connected to a gate line, an input terminal connected to a data line, and an output terminal connected to a pixel electrode.

[0008] In the case of a conventional liquid crystal display, light leakage is generated on the circumference of the data lines according to the space between the data lines and the pixel electrodes. To prevent the light leakage, a black matrix is extended on the common electrode panel. Such a device may result, however, in an aperture ratio of the entire liquid crystal display being reduced.

[0009] To solve this problem, a panel may be formed in which storage wiring for preventing the light leakage is formed under the data lines, and the pixel electrodes overlap the storage wiring to which the common signal is applied. In this panel, however, the data load is increased so that problems such as high heat and driving deterioration of the high voltage are generated.

[0010] Thus, there is a need for a liquid crystal display that prevents light leakage without reducing the aperture ratio of

the display. There is also a need for a liquid crystal display that prevents a reduction of aperture ratio without increasing the data load.

[0011] The above information disclosed in this Background section is only for enhancement of understanding of the background of the invention and therefore it may contain information that does not form the prior art that is already known in this country to a person of ordinary skill in the art.

SUMMARY

[0012] One or more embodiments of the present invention may prevent a reduction of aperture ratio without increasing a data load. For example, in one embodiment, a liquid crystal display includes: a first insulation substrate; a gate line extending in a first direction on the first insulation substrate; a data line insulated from the gate line and extending in a second direction; a pixel electrode formed in a pixel area defined by the intersection of the gate line and the data line; and storage wiring formed with the same layer as the data line, wherein the storage wiring includes a storage electrode extending in the first direction and covering the gate line, and a storage line connected to the storage electrode and formed according to the second direction.

[0013] The pixel area may have a longer length in the first direction than the second direction. The storage electrode may be wider than the gate line. The width of the storage electrode deviated from the gate line may be in the range of 1 μm (micrometer or micron) to 10 μm . The storage electrode may overlap the edge of the pixel electrode. The storage electrode may simultaneously overlap a pair of neighboring pixel electrodes with regard to the center of the gate line. The storage wiring may include a protrusion that is not overlapped with the pixel electrode.

[0014] The liquid crystal display may further include a bridge that is electrically connected to a pair of storage wires with regard to the center of the data line, and the bridge may be contacted with the protrusion of one of the pair of storage wires and the storage electrode of the other of the pair of storage wires. The bridge may be formed with the same material as the pixel electrode and is made of the same layer as the pixel electrode. The bridge may be made of ITO or IZO.

[0015] The storage line may overlap the edge of the second direction of the pixel electrode. The liquid crystal display may further include an assistance light blocking member overlapping the edge opposite to the edge overlapping the storage line among the edges of the second direction of the pixel electrode. The assistance light blocking member may be made of the same material and layer as the gate line.

[0016] The liquid crystal display may further include a second insulation substrate facing the first insulation substrate and a black matrix formed on the second insulation substrate and defining the pixel area, and the width of the storage electrode may be the same as the width of the black matrix.

[0017] The liquid crystal display may further include a thin film transistor including a source electrode, a drain electrode, and a semiconductor layer, and the semiconductor layer may be formed of an oxide semiconductor or a low temperature polysilicon. The oxide semiconductor may be made of a composition including two components such as Zn—O, In—O, Sn—O, Ga—O, Hf—O, Mg—O, and Cd—O, or a composition made of a combination thereof.

[0018] According to one embodiment of the present invention, a transverse pixel structure may be applied such that the

width of the black matrix is reduced, thereby improving the aperture ratio. Also, the storage wire may be formed with the same layer as the data line, and the storage wire and the pixel electrode may overlap each other in the edge region of the pixel electrode of the transverse pixel structure to form a storage capacitor such that the storage capacitance is increased with the same area compared with the conventional art. Also, the storage electrode may cover the gate line, thereby preventing a gate field.

BRIEF DESCRIPTION OF THE DRAWINGS

[0019] FIG. 1 is a layout view of a thin film transistor array panel according to an embodiment of the present invention.

[0020] FIG. 2 is a cross-sectional view taken along the line II-II' of FIG. 1 in accordance with an embodiment of the present invention.

[0021] FIG. 3 is a cross-sectional view taken along the line III-III' of FIG. 1 in accordance with an embodiment of the present invention.

[0022] FIG. 4 is a layout view of a liquid crystal display according to an embodiment of the present invention.

[0023] FIG. 5 is a cross-sectional view taken along the line V-V' of FIG. 4 in accordance with an embodiment of the present invention.

DETAILED DESCRIPTION

[0024] Exemplary embodiments of the present invention will be described in detail with reference to the accompanying drawings. However, the present invention is not limited to exemplary embodiments described herein, but may be embodied in other forms. Rather, exemplary embodiments described herein are provided to thoroughly and completely explain the disclosed contents and to sufficiently transfer the ideas of the present invention to a person of ordinary skill in the art.

[0025] In the drawings, the thickness of layers and regions is exaggerated for clarity. It is to be noted that when a layer is referred to as being "on" another layer or substrate, it can be directly formed on another layer or substrate or can be formed on another layer or substrate through a third layer interposed therebetween. Like constituent elements are denoted by like reference numerals throughout the specification.

[0026] FIG. 1 is a layout view of a thin film transistor array panel included in a liquid crystal display according to an exemplary embodiment of the present invention. FIG. 2 is a cross-sectional view taken along the line II-II' of FIG. 1, and FIG. 3 is a cross-sectional view taken along the line III-III' of FIG. 1 in accordance with one or more embodiments.

[0027] A thin film transistor array panel according to an embodiment of the present invention will be described with reference to FIG. 1, FIG. 2, and FIG. 3.

[0028] A thin film transistor array panel 100 according to an embodiment of the present invention includes gate wiring (121 and 124) formed on a first insulation substrate 110, an assistance light blocking member 122, storage wiring (131, 131a, and 131b), a gate insulating layer 140, a semiconductor layer 151, ohmic contact layers 163 and 165, data wiring (171, 173, and 177), a passivation layer 180, and a pixel electrode 191.

[0029] The first insulation substrate 110 may be made of a material having heat resistance and light transmittance such as transparent glass or plastic.

[0030] The gate wiring (121 and 124) extending in a first direction is formed on the first insulation substrate 110. The gate wiring (121 and 124) extends in the first direction, for example the transverse direction, and includes a gate line 121 transmitting gate signals and a gate electrode 124 protruding from the gate line 121 as a protrusion. The gate electrode 124 is one of three terminals of the thin film transistor along with a source electrode 173 and a drain electrode 175 that are will be described later. The gate wiring (121 and 124) may be made of a metal having low resistance such as an aluminum-based metal of aluminum (Al) or aluminum alloys, a silver-based metal of silver (Ag) or silver alloys, and a copper-based metal of copper (Cu) or copper alloys. However, they may have a multilayered structure including two conductive layers (not shown) having different physical properties, and they may be made of various other metals or electrical conductors.

[0031] The gate insulating layer 140 covering the gate wiring (121 and 124) is formed on the first insulation substrate 110. The gate insulating layer 140 may be made of silicon oxide (SiO_x) or silicon nitride (SiN_x).

[0032] The semiconductor layer 151 that is made of hydrogenated amorphous silicon, polysilicon, or a conductive organic material is formed on the gate insulating layer 140. However, in an exemplary embodiment of the present invention, it is preferable that the semiconductor layer 151 is made of an oxide semiconductor or a low temperature polysilicon (LTPS) to improve the mobility of the current.

[0033] Here, the oxide semiconductor has mobility of several times or several tens of times compared with the hydrogenated amorphous silicon. The oxide semiconductor may be made of one composition including a two-component group such as In—O, Sn—O, Ga—O, Hf—O, Mg—O, Cd—O, and Zn—O, or may be a composition made of a combination thereof. For example, it may be an amorphous oxide semiconductor (a-IGZO) based on zinc oxide (ZnO), InGaO₃ (ZnO)₅, magnesium zinc oxide (Mg_zZn_{1-x}O), cadmium zinc oxide (Cd_zZn_{1-x}O), cadmium oxide (CdO), or In—Ga—Zn—O. It is possible that the oxide semiconductor exists in an amorphous state, a crystalline state, or a micro-crystalline state in which an amorphous state and a crystalline state coexist.

[0034] The LTPS is formed by a technique in which thin film transistors are formed on a glass substrate at a temperature of less than 600 degrees with a laser, thereby forming a thin film transistor liquid crystal display with a large size, as with the conventional amorphous silicon (a-Si). When the semiconductor layer 151 is formed of the oxide semiconductor and has the LTPS applied to it, high speed driving may be realized through the excellent electrical characteristics obtained.

[0035] The semiconductor layer 151 may have various shapes such as an island shape or a stripe shape, and for example, when the semiconductor layer 151 is formed with an island shape as in an embodiment of the present invention, the semiconductor layer 151 may overlap the gate electrode 124 and partially overlap the source electrode 173 and the drain electrode 175 that will be described. The semiconductor layer 151 is not limited by the island shape and may be variously formed.

[0036] The ohmic contact layers 163 and 165 that are made of a material such as silicide, n+ hydrogenated amorphous silicon doped with an n-type impurity at a high concentration, or ITO doped with a p-type impurity, are formed on the semiconductor layer 151. The ohmic contact layers 163 and

165 are disposed as a pair on the semiconductor layer **151**, and improve the contact characteristic between the source electrode **173** and drain electrode **175** and the semiconductor layer **151**. When the contact characteristic between the source electrode **173** and drain electrode **175** and the semiconductor layer **151** is sufficient, the ohmic contact layers **163** and **165** may be omitted.

[0037] The data wiring (**171**, **173**, and **177**) is formed on the semiconductor layer **151** and the gate insulating layer **140**. The data wiring (**171**, **173**, and **177**) includes a data line **171** extending in the second direction (the longitudinal direction) and transmitting a data signal, the source electrode **173** branched from the data line **171** and extending on the semiconductor layer **151**, and the drain electrode **175** separated from the source electrode **173** and facing the source electrode **173**. The data line **171** is insulated from and intersects the gate line **121**, thereby defining a pixel area.

[0038] The source electrode **173** branched from the data line may have a “j” shape, and overlaps a portion of the semiconductor layer **151**.

[0039] One end of the drain electrode **175** is close to the concave portion of the source electrode **173** with the “j” shape, and at least overlaps the portion of the semiconductor layer **151**.

[0040] On the other hand, an expansion **177** extended from one end of the drain electrode **175** is electrically connected to the pixel electrode **191** and has a wider width than the drain electrode **175**. The expansion **177** of the drain electrode **175** may be formed outside of the pixel area in order not to reduce the aperture ratio. Here, the pixel area is a region defined by the gate wiring (**121** and **124**) and the data wiring (**171**, **173**, and **177**). The pixel area is a region where the light emitted from the backlight assembly passes through. Accordingly, a color filter region of a color filter panel corresponding to the pixel area of the thin film transistor array panel **100** is the pixel area.

[0041] It is preferable that the pixel area in an embodiment of the present invention is formed to have a longer length in the first direction (e.g., direction of the gate line **121**) of the pixel area than in the second direction (e.g., direction of the data line **171**).

[0042] The data wiring (**171**, **173**, and **177**) may be made of a metal such as chromium and molybdenum, or a refractory metal such as tantalum and titanium, and may have a multi-layered structure including a lower layer (not shown) of a refractory metal and an upper layer (not shown) of a low resistance material. Also, like the gate wiring (**121** and **124**), the data wiring (**171**, **173**, and **177**) may be made of a metal having low resistance such as an aluminum-based metal of aluminum (Al) or aluminum alloys, a silver-based metal of silver (Ag) or silver alloys, and a copper-based metal of copper (Cu) or copper alloys.

[0043] The gate electrode **124**, the source electrode **173**, and the drain electrode **175** form a thin film transistor along with the semiconductor layer **151**, and the channel of the thin film transistor is formed in the semiconductor layer **151** between the source electrode **173** and the drain electrode **175**.

[0044] A passivation layer **180** is formed on the data wiring (**171**, **173**, and **175**) and the storage wiring (**131**, **131a** and **131b**), and the exposed semiconductor layer **151**. The passivation layer **180** may be made of an inorganic insulator or an organic insulator, and may have a flat surface. The organic insulator may have a dielectric constant less than 4.0, and photosensitivity.

[0045] The storage wiring (**131**, **131a**, and **131b**) is formed with the same layer as the data wiring (**171**, **173**, and **177**). The storage wiring (**131**, **131a**, and **131b**) includes a storage electrode **131** covering the gate line **121**, and the storage electrode **131** is formed in the same direction as the first direction of the gate line **121**.

[0046] The storage electrode **131** simultaneously overlaps a pair of neighboring pixel electrodes **191** with regard to the gate line **121**. The width **W1** of the storage electrode **131** is wider than the width **W2** of the gate line **121**.

[0047] The storage electrode **131** is disposed on the gate line **121**, thereby having a light blocking function. Also, a storage capacitor is formed between the storage electrode **131** of the storage wiring with the same layer as the data line **171**, the passivation layer **180**, and the pixel electrode **191** such that the interval between the electrodes (e.g., storage electrode **131** and pixel electrode **191**) is reduced compared with the case in which the storage wiring is formed with the same layer as the gate line (i.e., further from the pixel electrode), and thereby a larger storage capacitance may be formed with the same area. Further, the data line **171** and the storage wiring (**131**, **131a**, and **131b**) do not overlap each other, and thus, the data load is reduced, thereby reducing the power consumption. As a substitute, the gate load is increased, as described above. The semiconductor layer **151**, however, may be formed of the oxide semiconductor or applied with the low temperature polysilicon (LTPS) such that the mobility is improved, and thereby problems due to increasing the gate load may be ameliorated or avoided.

[0048] The storage wiring (**131**, **131a**, and **131b**) may be made of the same material as the data wiring (**171**, **173**, and **175**).

[0049] The storage wiring (**131**, **131a** and **131b**) includes a storage line **131a** connected to the storage electrode **131** and extending according to the second direction. The storage line **131a** is separated from the data line **171** and arranged parallel to the data line **171**. The storage line **131a** is disposed to overlap the edge of the pixel electrode **191** in the second direction such that the storage capacitor may be formed between the pixel electrode **191** and the storage line **131a**.

[0050] At least a portion of the storage line **131a** does not overlap the pixel electrode **191**. In detail, the storage line **131a** is wholly parallel to the data line **171**, however a portion of the storage line **131a** forms a protrusion **131b** protruded outside of the pixel electrode **191** such that the protrusion **131b** does not overlap the pixel electrode **191**. The protrusion **131b** is protruded toward the data line **171** close to the storage line **131a**, and does not overlap the gate wiring (**121** and **124**) and the data wiring (**171**, **173**, and **177**). The shape of the protrusion **131b** may be like a “□” shape, however if it does not overlap the pixel electrode **191**, may be changed such as to a circular arc shape, a “人” shape.

[0051] An assistance light blocking member **122** is formed overlapping the edge of the pixel electrode **191** opposite to the edge of the pixel electrode **191** overlapping the storage line **131a** and along the edge of the pixel electrode **191** in the second direction. The assistance light blocking member **122** is made of the same material as the gate line **121**, and is disposed with the same layer as the gate line **121**. The assistance light blocking member **122** has a function of blocking light leakage generated between the data line **171** and the pixel electrode **191**.

[0052] The passivation layer **180** has a plurality of contact holes **183a**, **183b**, and **185** exposing the wide end portion **177**

of the drain electrode **175** and the storage wiring (**131**, **131a**, and **131b**). The pixel electrode **191** and a bridge **83** are formed on the passivation layer **180**. They may be made of a transparent conductive material such as indium tin oxide (ITO) or indium zinc oxide (IZO), or a reflective metal such as aluminum, silver, chromium, or alloys thereof.

[0053] The pixel electrode **191** is physically and electrically connected to the drain electrode **175** through the contact hole **185**, and receives data voltages from the drain electrode **175**.

[0054] In the liquid crystal display according to the present invention, the bridge **83** electrically connects neighboring storage wiring (**131**, **131a**, and **131b**). In detail, the bridge **83** is connected to one storage line **131a** among the storage wiring (**131**, **131a**, and **131b**) and to a storage electrode **131** among another, second storage wiring (**131**, **131a**, and **131b**). The bridge **83** is electrically connected to the protrusion **131b** of the storage line **131a** of the storage electrodes **131** through the contact holes **183a** and **183b**.

[0055] A bridge **83** may be formed at every pixel area. In other words, the bridge **83** may be all formed at all pixel areas that are defined as a red pixel area, a green pixel area, or a blue pixel area according to a corresponding color filter **230** that will be described later. A pixel electrode **191** of a pixel area having a bridge **83** may have a smaller area than a pixel electrode of a pixel area without a bridge **83**. That is, a corner portion of a pixel electrode **191** is cut out from the pixel electrode **191** to form a bridge **83** such that the pixel electrode **191** of the pixel area having the bridge **83** is electrically separated from the bridge **83**.

[0056] The bridge **83** may be formed in all pixel areas, or it may be formed in two pixel areas among the above-described pixel areas or it may be formed in one pixel area. One pixel area may be a blue pixel area in which the luminance is lowest. When the bridge **83** is formed at every blue pixel area in which the luminance is lowest, a reduction of luminance according to the formation of the bridge **83** may be minimized, and a spacer of the color filter panel that will be described later is formed on a portion corresponding to the bridge **83** such that the reduction of the aperture ratio due to the spacer may be prevented.

[0057] FIG. 4 is a layout view of a liquid crystal display according to an embodiment of the present invention. FIG. 5 is a cross-sectional view taken along the line V-V' of FIG. 4 in accordance with an embodiment.

[0058] Referring to FIG. 4 and FIG. 5, the pixel electrodes **191**, having the data voltages applied, and a common electrode **270** of the color filter panel **200** generate an electric field that determines the orientations of liquid crystal molecules of a liquid crystal layer **3** (see FIG. 5) between two electrodes **191** and **270**.

[0059] A color filter panel **200** includes a black matrix **220**, the color filter **230**, an overcoat **250**, and the common electrode **270**, which are formed on the lower surface of a second insulation substrate **210**, and is disposed to be opposite to the thin film transistor array panel **100**.

[0060] The second insulation substrate **210** of the color filter panel **200** may be made of a material having thermal resistance and light transmittance, such as glass or plastic.

[0061] The black matrix **220** blocks light leakage between the pixel electrodes **191** and defines an opening facing each pixel electrode **191**. The black matrix **220** is formed of an opaque material such as chromium (Cr), and defines the pixel area in a matrix shape in the first direction and the second

direction. A width **W3** of the first direction, for example the transverse direction, may be formed with the same width **W1** of the storage electrode **131** of the storage wiring, and thereby the aperture ratio is not decreased.

[0062] It is preferable that widths **A** and **A'** of the storage electrode **131** away from the gate line **121** are in the range of 1 μm (micrometer or micron) to 10 μm . If the widths **A** and **A'** are excessively small, the effect of blocking a gate field is reduced, and if the widths **A** and **A'** are excessively large, the aperture ratio may be decreased.

[0063] The effect according to an embodiment of the present invention will now be described in detail.

[0064] When storage wiring is formed with the same layer as the gate line and overlaps data line thereunder under the longitudinal pixel structure, a margin for preventing light leakage by the lateral electric field between the data line and the pixel electrode is required and the width of the black matrix is about 19.5 μm .

[0065] When the liquid crystal display according to an embodiment of the present invention is a normally black mode display, the voltage of the storage electrode **131** and the pixel voltage of the black state are equal such that light leakage between the storage electrode **131** and the pixel electrode **191** is not generated (it is assumed that the voltage of the storage electrode is 0 V), and accordingly the aperture ratio is improved. Here, the normally black mode is a mode in which the incident light is totally blocked by the liquid crystal panel in a state in which the application voltage does not exist such that the luminance is lowest, and the application voltage is over a threshold voltage such that the light is transmitted.

[0066] Again referring to FIG. 4 and FIG. 5, if the widths **A** and **A'** of the storage electrode **131** away from the gate line **121** is defined as a first interval, the first interval is a margin required for the function of preventing the gate field. Generally, the first interval (**A** and **A'**) is in the range of 2.0 μm to 3.5 μm . If the width **W2** of the gate line **121** is 7 μm , the entire width **W1** of the storage electrode **131** is in the range of 12 μm to 14 μm such that the width **W3** of the black matrix may be reduced compared with the conventional 19.5 μm . In the case of the transverse pixel structure, the danger of color mixture does not exist so that it is possible to reduce the width **W3** of the black matrix.

[0067] When the liquid crystal display according to an embodiment of the present invention is a normally white mode display, a lateral electric field is generated between the storage electrode **131** and the pixel electrode **191** in the black state such that light leakage is generated between the storage electrode **131** and the pixel electrode **191**. Here, the normally white mode means a mode in which the light is transmitted in the state in which the voltage is not applied, thereby obtaining maximum luminance, contrary to the normally black mode.

[0068] If it is assumed that in the conventional case driving occurs at 4.0 V, the application voltage of the source/drain is in the range of AC +4.0 to -4.0 V. In the black state in dot inversion, a potential difference between the data line and the pixel electrode is in the range of 0 to 8.0 V as the lateral electric field under the pixel voltage of +4.0 V, and a root mean square (RMS) may be 4.0 V. In detail, a distortion amount of the liquid crystal director is larger than the case in which the 4.0 V value is uniformly maintained. In contrast, in the liquid crystal display according to an embodiment of the present invention, the application voltage of the storage wiring (**131**, **131a** and **131b**) is DC 0 V such that a voltage difference between the pixel voltage and the storage voltage is

always 4.0 V under positive inversion and negative inversion. Accordingly, the distortion amount of the liquid crystal director is smaller than the conventional such that it is possible to reduce the width W3 of the black matrix.

[0069] A plurality of color filters 230 are formed on the second insulation substrate 210 and the black matrix 220. The color filters 230 are mainly disposed in the regions enclosed by the black matrix 220, and may extend according to the column of the pixel electrodes 191. Each of color filters 230 may display one of primary colors such as three primary colors of red, green, and blue.

[0070] An overcoat 250 is formed on the color filters 230 and the black matrix 220. The overcoat 250 may be made of an (organic) insulating material, and it prevents the color filters 230 from being exposed and provides a plane surface.

[0071] A common electrode 270 is formed on the overcoat 250. The common electrode 270 is made of the transparent conductor such as ITO or IZO, and is applied with a common voltage Vcom.

[0072] Alignment layers (not shown) are coated on the first and second insulation substrates 110 and 210, and they may be vertical alignment layers.

[0073] Polarizers (not shown) may be provided on the first and second insulation substrates 110 and 210, the transmissive axes of the two polarizers are crossed, and one transmissive axis may be parallel to the gate lines 121.

[0074] The liquid crystal layer 3 (see FIG. 5) between the thin film transistor array panel 100 and the color filter panel 200 may include liquid crystal molecules having negative dielectric anisotropy, and the liquid crystal molecules may be aligned such that their major axes are perpendicular to the surfaces of the two panels 100 and 200 in the absence of an electric field.

[0075] Also, although not shown, spacers for maintaining a uniform interval along the thin film transistor array panel 100 may be formed on the pixel electrodes 191, and the liquid crystal layer 3 may be interposed in the interval maintained by the spacers.

[0076] While this invention has been described in connection with what is presently considered to be practical exemplary embodiments, it is to be understood that the invention is not limited to the disclosed embodiments, but, on the contrary, is intended to cover various modifications and equivalent arrangements included within the spirit and scope of the appended claims. Thus, numerous modifications and variations are possible in accordance with the principles of the present disclosure. Accordingly, the scope of the disclosure is defined only by the following claims.

What is claimed is:

1. A liquid crystal display comprising:

a first insulation substrate;

a gate line extending in a first direction on the first insulation substrate;

a data line insulated from the gate line and extending in a second direction;

a pixel electrode formed in a pixel area defined by the intersection of the gate line and the data line; and

storage wiring formed with the same layer as the data line, wherein the storage wiring includes a storage electrode extending in the first direction and covering the gate line, and a storage line connected to the storage electrode and formed according to the second direction.

2. The liquid crystal display of claim 1, wherein the pixel area has a longer length in the first direction than the second direction.

3. The liquid crystal display of claim 2, wherein the storage electrode is wider than the gate line.

4. The liquid crystal display of claim 3, wherein the width of the storage electrode deviated from the gate line is in a range of 1 μm to 10 μm .

5. The liquid crystal display of claim 3, wherein the storage electrode overlaps an edge of the pixel electrode.

6. The liquid crystal display of claim 4, wherein the storage electrode simultaneously overlaps a pair of neighboring pixel electrodes with regard to a center of the gate line.

7. The liquid crystal display of claim 6, wherein the storage wiring includes a protrusion that is not overlapped with the pixel electrode.

8. The liquid crystal display of claim 7, further comprising a bridge that is electrically connected to a pair of storage wires with regard to the center of the data line, and the bridge contacts the protrusion of one of the pair of storage wires and the storage electrode of the other of the pair of storage wires.

9. The liquid crystal display of claim 8, wherein the bridge is formed with the same material as the pixel electrode and is made of the same layer as the pixel electrode.

10. The liquid crystal display of claim 9, wherein the bridge is made of ITO or IZO.

11. The liquid crystal display of claim 1, wherein the storage line overlaps an edge of the second direction of the pixel electrode.

12. The liquid crystal display of claim 11, further comprising an assistance light blocking member overlapping an edge opposite to the edge overlapping the storage line among the edges of the second direction of the pixel electrode.

13. The liquid crystal display of claim 12, wherein the assistance light blocking member is made of the same material and layer as the gate line.

14. The liquid crystal display of claim 1, further comprising: a second insulation substrate facing the first insulation substrate; and

a black matrix formed on the second insulation substrate and defining the pixel area, wherein the width of the storage electrode is the same as the width of the black matrix.

15. The liquid crystal display of claim 1, further comprising a thin film transistor including a source electrode, a drain electrode, and a semiconductor layer, and the semiconductor layer is formed of an oxide semiconductor or a low temperature polysilicon.

16. The liquid crystal display of claim 15, wherein the oxide semiconductor is made of a composition including two components such as Zn—O, In—O, Sn—O, Ga—O, Hf—O, Mg—O, and Cd—O, or a composition made of a combination thereof.

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专利名称(译)	液晶显示器		
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摘要(译)

对于一个实施例，液晶显示器包括第一绝缘基板；在第一绝缘基板上沿第一方向延伸的栅极线；数据线与栅极线绝缘并沿第二方向延伸；像素电极形成在由栅极线和数据线的交叉点限定的像素区域中；形成有与数据线相同的层的存储布线，其中，存储布线包括沿第一方向延伸并覆盖栅极线的存储电极，以及连接到存储电极并根据第二方向形成的存储线。

